

Active tuning of the optical response of field-effect-gated transparent conductive oxides

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Abstract. Transparent Conductive Oxides (TCOs) are a class of materials with high optical transparency and electrical conductivity. This combination makes them extremely appealing for solar cells, optoelectronics and infrared-plasmonics applications. In this work, we report the active tuning of the optical response of aluminium-doped ZnO (AZO) films upon electrical gating within a parallel-plate capacitor configuration. We investigated the electrical-bias-dependent optical response of thin AZO films fabricated by pulsed laser deposition by means of spectroscopic ellipsometry (SE). Calculations based on an exponentially-decaying spatial distribution of injected/depleted charge density in the AZO film are in accordance with experimental observations, allowing the extraction of the Debye length.

1 Introduction

The realisation of active optoelectronic systems has drawn the attention of the scientific community over the last decade due to the possibility of merging optical and electrical control in a single device for next generation optoelectronics and photovoltaics. TCOs (such as ITO, ZnO etc.) are characterised by a combination of high optical transparency (~80%) and low electrical resistivity ($\sim 10^{-4} \Omega \cdot \text{cm}$).

Zinc oxide (ZnO) is a n-type semiconductor with direct wide-energy band gap, and is a possible cheaper substitute to the commonly used indium-tin oxide. Aluminium doping increases its conductivity and makes it suitable for applications in optoelectronic devices, as a transparent conductive component and epsilon-near-zero (ENZ) material in the near infrared (NIR).

Actively modifying the optical response of TCOs via field effect is a potentially viable strategy to develop new functional optical materials for optoelectronics, photonics and photovoltaics ([1-2]). Under an applied electric field, the carrier concentration at a dielectric/conducting oxide interface induces charge accumulation/depletion in a thin layer whose width is usually less than 5 nm due to screening effects. Most of the studies about voltage-gated optically-active TCOs have focused on ITO-based systems, and have been

limited to reflectance/transmission measurements within the visible and -NIR regimes.

In this study, we show the active tuning of the optical response of thin AZO films on SrTiO₃(110) substrates (STO) via field effect, in a spectral range encompassing both the visible and near infrared (NIR) photon-energy range (0.735 to 3.22 eV). The TCO film acts as the top electrode in a parallel-plate-capacitor configuration. We successfully observed the active tuning of the optical response of AZO, and quantified the charge profile of the accumulation layer at the TCO/insulator interface.

2 Discussion

In order to realise a large charge modulation AZO films were grown on STO(110) substrates by Pulsed Laser Deposition (PLD). Spectroscopic Ellipsometry (SE) was performed by means of a J.A. Woollam V-VASE ellipsometer. For the SE measurements, the sample was mounted inside an optical cryostat (Oxford Instruments Optistat CF-V) and kept at either 4.2 K or 77 K temperature.

In order to investigate the variations of the optical response of the AZO films upon gating, we applied voltages of ± 100 V across the STO substrate, and acquired SE spectra under bias ($V = \pm 100$ V) (Figure 1).

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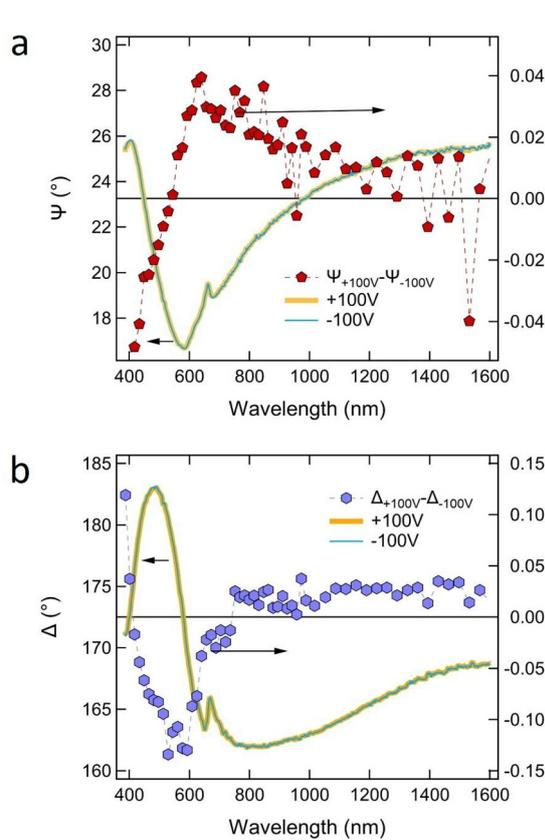


Fig. 1. a (b): Ellipsometry spectra $\Psi(\lambda)$ ($\Delta(\lambda)$) of 0.2 at.% AZO on top of STO (110) under bias (orange line: +100V, cyan line: -100V). Red (indigo) squares: Difference spectra $\delta\Psi(\lambda)$ ($\delta\Delta(\lambda)$), defined as $\Psi(+100V) - \Psi(-100V)$ ($\Delta(+100V) - \Delta(-100V)$). All spectra were acquired at $T=4.2$ K with an incidence angle of 45° .

An estimate of the gating-induced charge variation in the AZO can be obtained modelling the system as a parallel-plate capacitor, where the STO acts as the dielectric, and the metallic contact at the back of the substrate and the AZO film are the two electrodes. Then, we assume that the injected/depleted charge density exhibit an exponential depth grading, that can be written as:

$$N_e(z) = N_0 \pm \left(\frac{\sigma_e}{\lambda_D}\right) e^{-\frac{z}{\lambda_D}} \quad (1)$$

where σ_e is the surface charge density on the plates of the capacitor, N_0 is the charge density of unbiased AZO, λ_D is the Debye length, that accounts for the screening length inside the AZO while the \pm case corresponds to the injection/depletion case, respectively. Knowing $N_e(z)$, it becomes possible to simulate the optical response of the system, just applying a corresponding variation to the Drude term (Figure 2).

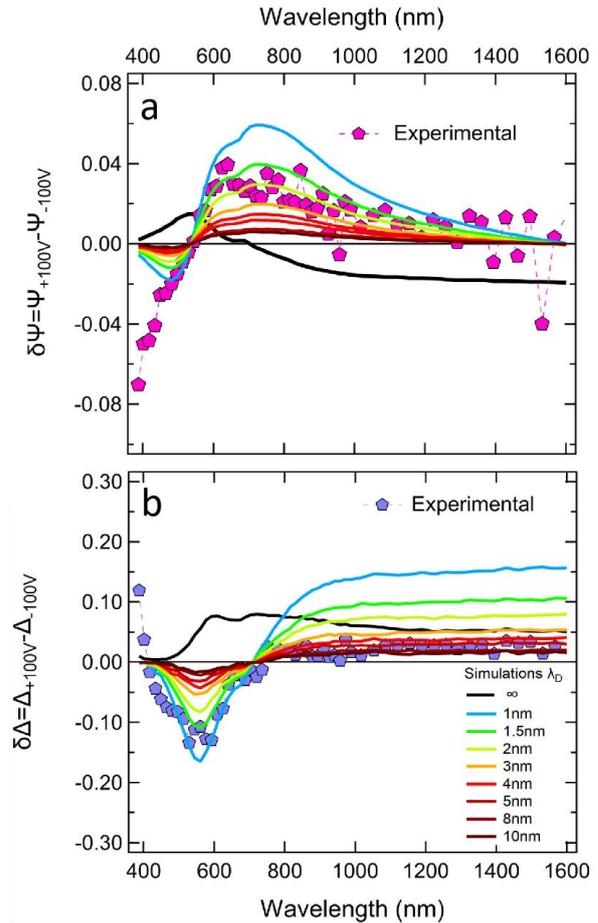


Fig. 2. a (b): Magenta (indigo) symbols: experimental difference spectra $\delta\Psi$ ($\delta\Delta$) as a function of wavelength, at $T=4.2$ K. Solid lines: calculated difference spectra obtained by modelling the charge injection/depletion in the AZO film. Different colours represent different values of the Debye length in the AZO film.

3 Conclusions

We have performed an in-operando optical spectroscopy investigation of the AZO/STO(110) system under field effect. The optical data shown here, and the related modelling, represent a great enrichment with respect to electrical-transport measurements alone, contributing to a deeper understanding of the phenomena.

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References

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